



US007545465B2

(12) **United States Patent**
Nam

(10) **Patent No.:** **US 7,545,465 B2**
(45) **Date of Patent:** **Jun. 9, 2009**

(54) **TRANSFLECTIVE LIQUID CRYSTAL
DISPLAY DEVICE AND FABRICATING
METHOD THEREOF**

(75) Inventor: **Chul Nam**, Gangneung-si (KR)

(73) Assignee: **LG. Display Co., Ltd.**, Seoul (KR)

(*) Notice: Subject to any disclaimer, the term of this
patent is extended or adjusted under 35
U.S.C. 154(b) by 51 days.

(21) Appl. No.: **11/025,219**

(22) Filed: **Dec. 28, 2004**

(65) **Prior Publication Data**

US 2005/0140879 A1 Jun. 30, 2005

(30) **Foreign Application Priority Data**

Dec. 29, 2003 (KR) 10-2003-0099358

(51) **Int. Cl.**
G02F 1/1335 (2006.01)

(52) **U.S. Cl.** **349/114**; 349/113

(58) **Field of Classification Search** 349/113,
349/114

See application file for complete search history.

(56) **References Cited**

U.S. PATENT DOCUMENTS

6,124,971 A 9/2000 Ouderkirk et al.
6,262,842 B1 7/2001 Ouderkirk et al.

6,285,426 B1 * 9/2001 Akins et al. 349/114
6,538,711 B2 * 3/2003 Funahata et al. 349/113
6,750,932 B2 * 6/2004 Kim 349/114
6,924,858 B2 * 8/2005 Nagayama et al. 349/113
2003/0038907 A1 * 2/2003 Ikeno et al. 349/113
2003/0090607 A1 5/2003 Kamijo
2004/0021810 A1 * 2/2004 Kawaguri et al. 349/113
2004/0056997 A1 * 3/2004 Yoshii et al. 349/113

FOREIGN PATENT DOCUMENTS

CN 1414416 4/2006
WO WO 03/052724 6/2006

* cited by examiner

Primary Examiner—David Nelms

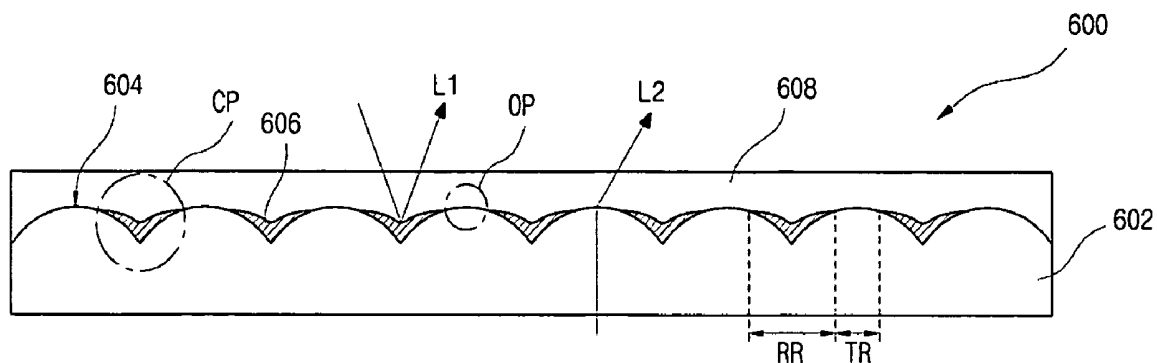
Assistant Examiner—Nathanael R Briggs

(74) *Attorney, Agent, or Firm*—Brinks Hofer Gilson & Lione

(57) **ABSTRACT**

A transfective liquid crystal display device includes opposing substrates having a liquid crystal layer interposed between the substrates. Polarizers are disposed on outer sides of the substrates. An uneven transfective film is disposed on one of the polarizers. A backlight unit is disposed outside of the uneven transfective film. The uneven transfective film includes a base film, convex patterns on the base film and a reflective layer in concave portions between the convex patterns. A passivation layer is disposed on the convex patterns and the reflective layer. Light from the backlight unit is transmitted through the convex patterns and ambient light is reflected by the reflective layer in the concave portions.

6 Claims, 8 Drawing Sheets



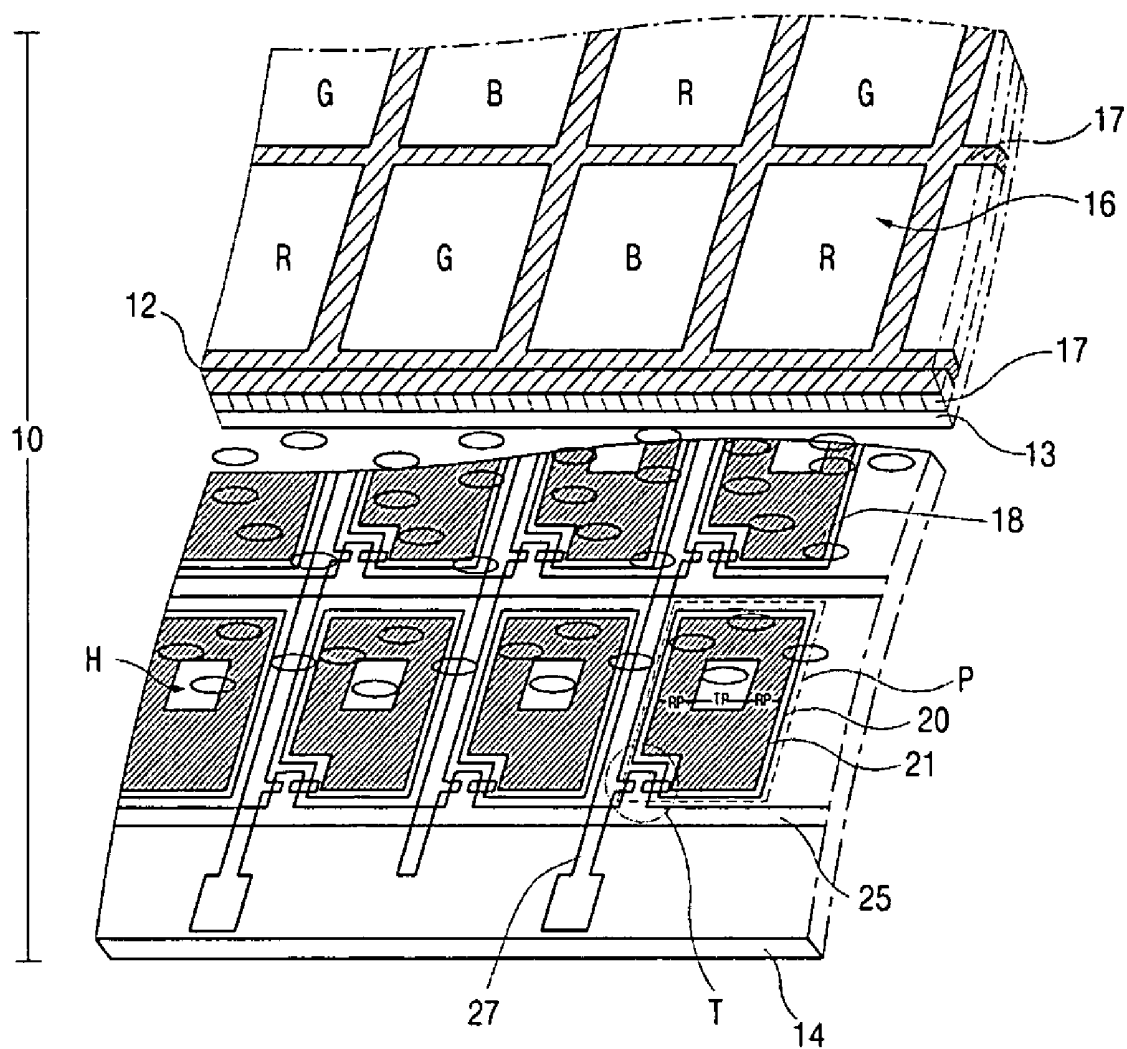


FIG. 2

RELATED ART

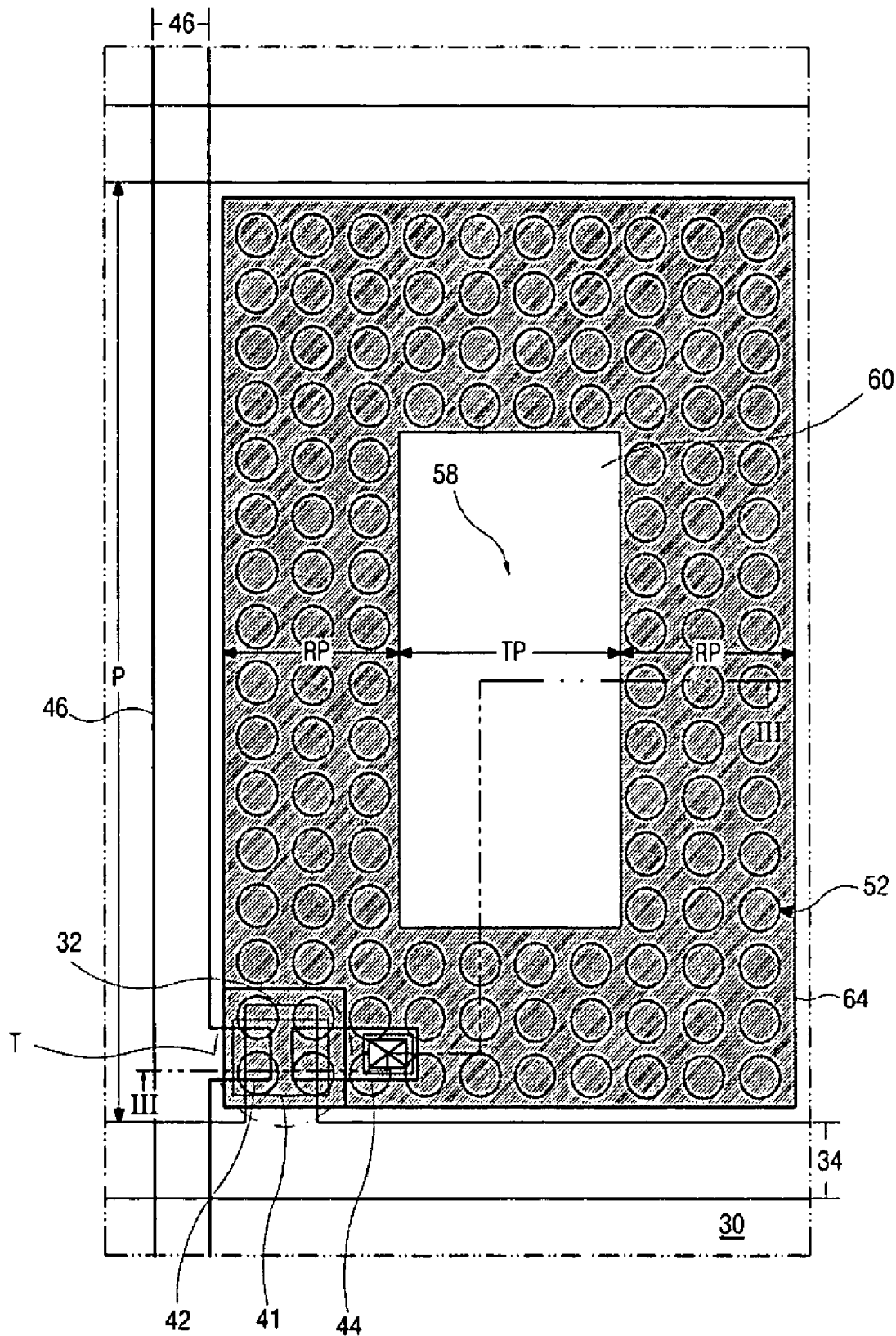


FIG. 3A
RELATED ART

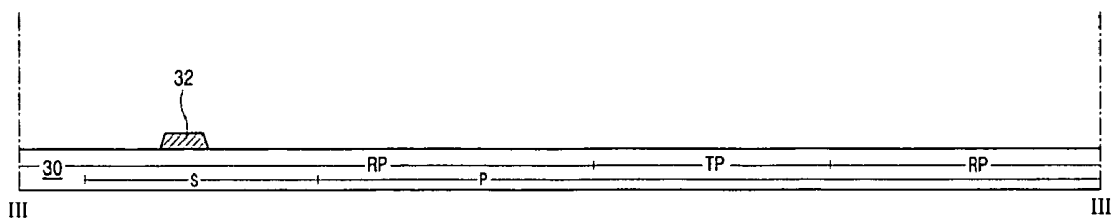


FIG. 3B
RELATED ART

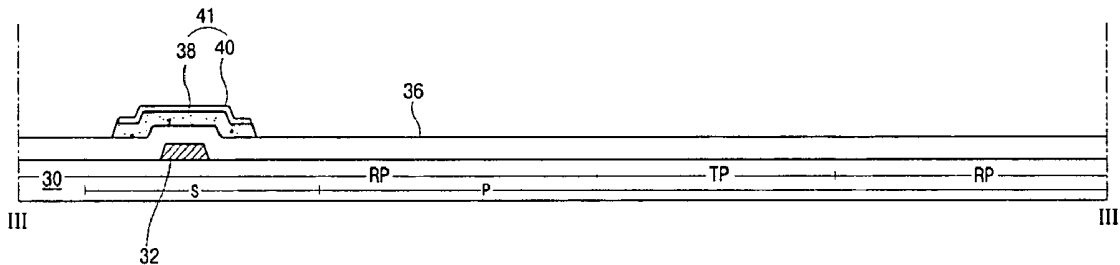


FIG. 3C
RELATED ART

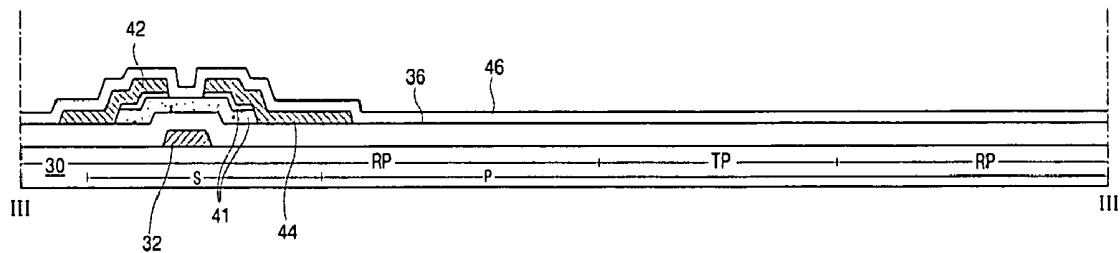


FIG. 3D
RELATED ART

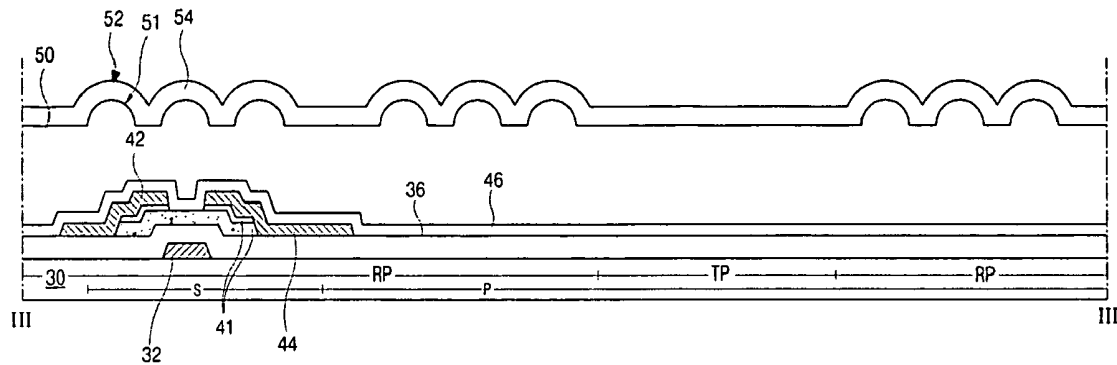


FIG. 3E
RELATED ART

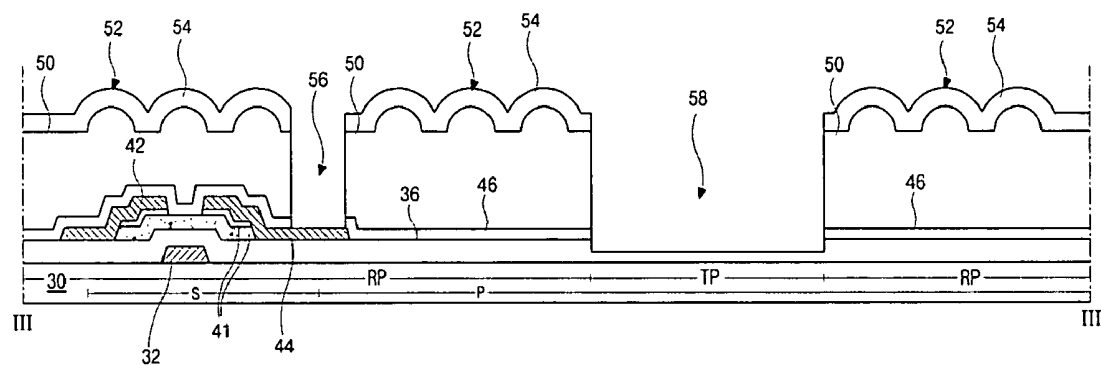
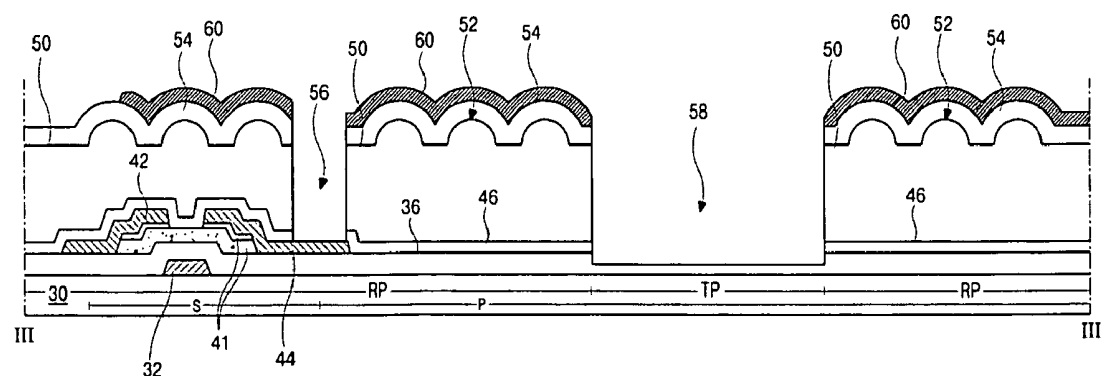


FIG. 3F
RELATED ART



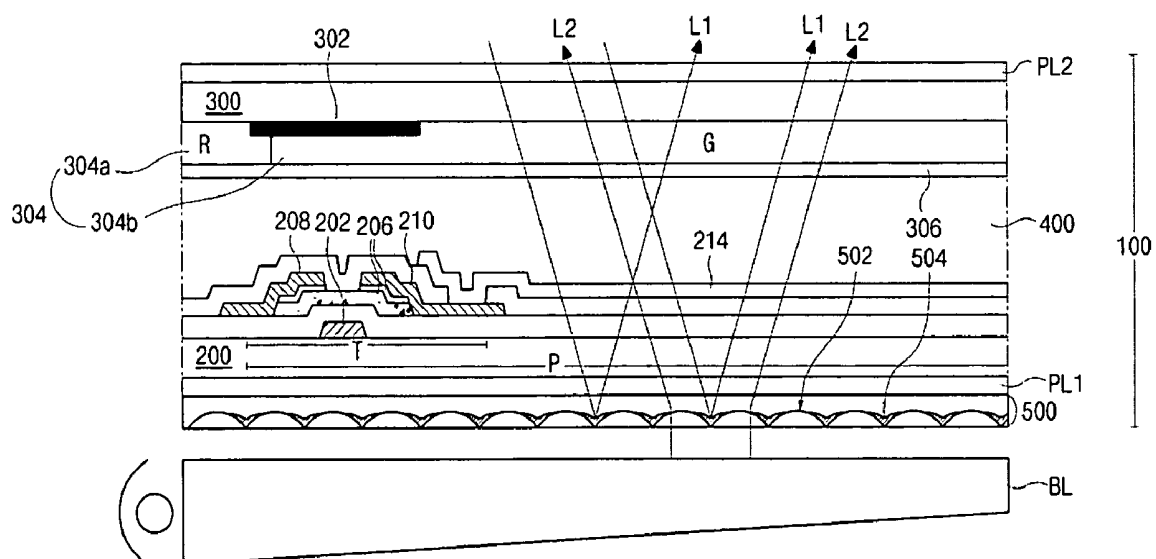


FIG. 5

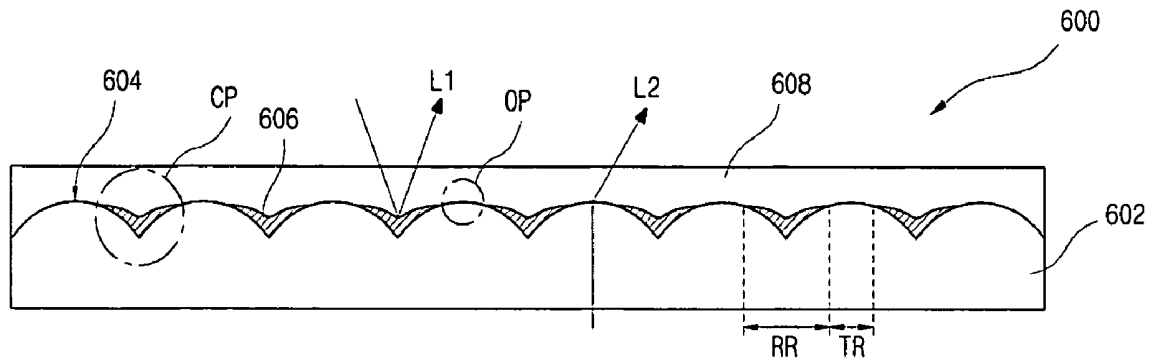


FIG. 6A



FIG. 6B

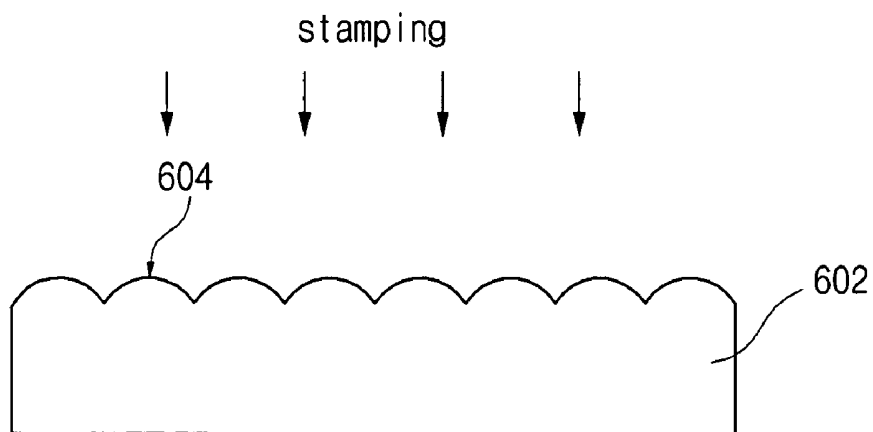


FIG. 6C

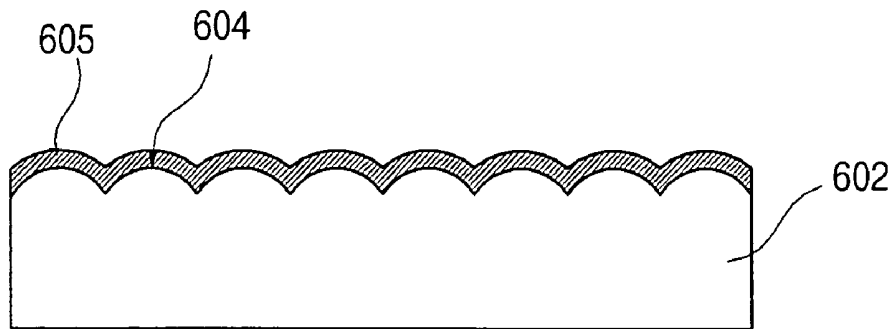


FIG. 6D

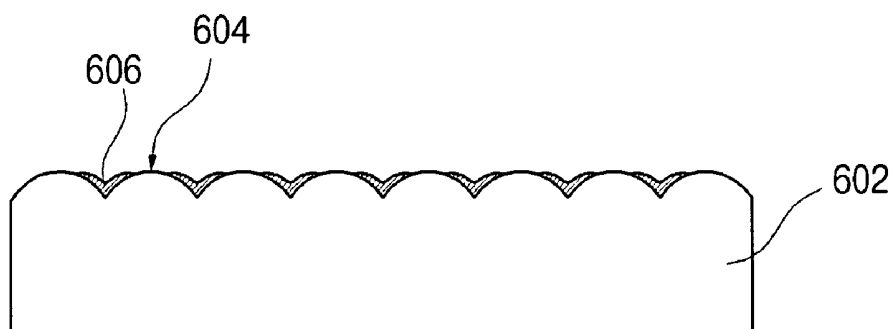


FIG. 6E

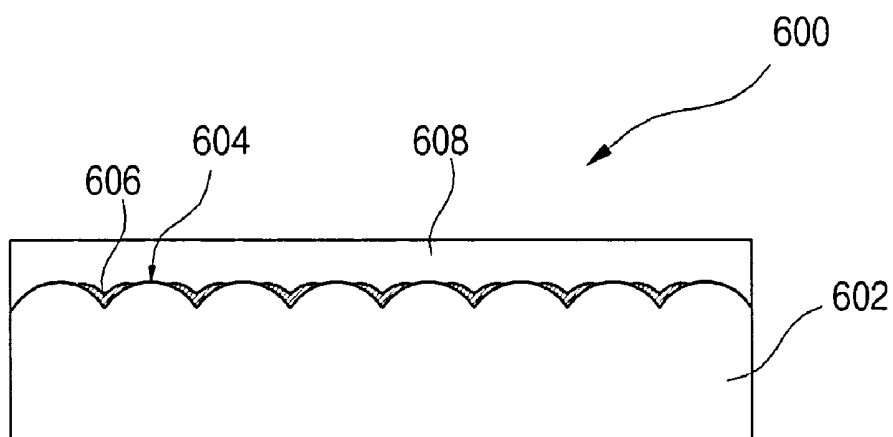
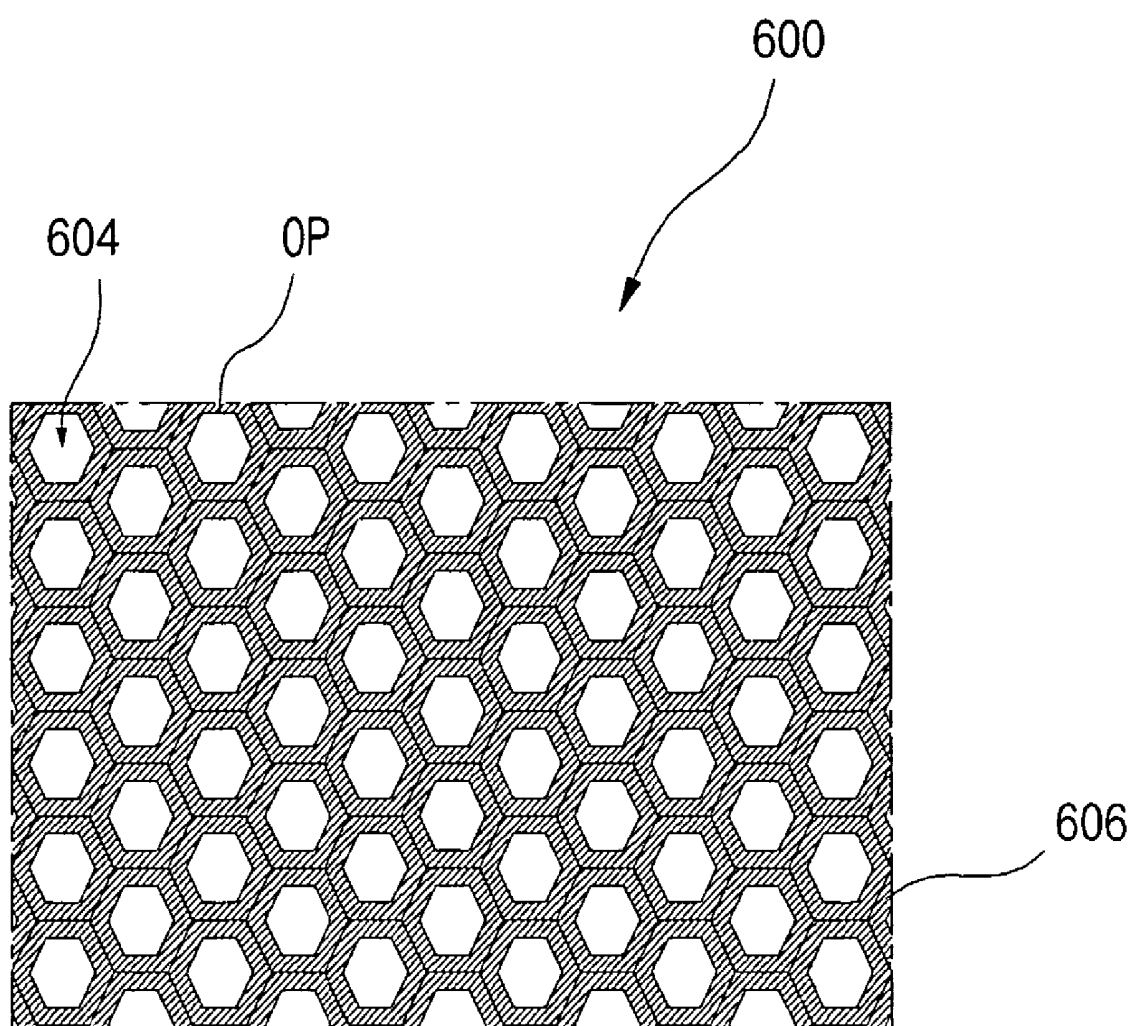


FIG. 7



TRANSFLECTIVE LIQUID CRYSTAL DISPLAY DEVICE AND FABRICATING METHOD THEREOF

This application claims the benefit of the Korean Patent Application No. 2003-99358, filed in Korea on Dec. 29, 2003, which is hereby incorporated by reference for all purposes as it fully set forth herein.

BACKGROUND

1. Field

The present invention relates to a liquid crystal display device, and more particularly, to a transfective liquid crystal display device having high utilization efficiency for light and a fabricating method thereof.

2. Discussion of the Related Art

Generally, transfective liquid crystal display (LCD) devices function as both transmissive and reflective LCD devices. Because transfective LCD devices can use both a backlight and natural or artificial ambient light, the transfective LCD devices may be used in more circumstances, and power consumption of transfective LCD devices may be reduced.

FIG. 1 is an exploded perspective view of an LCD device according to the related art. As shown in FIG. 1, a liquid crystal display (LCD) device 10 has an upper substrate 12 having a black matrix 17, a color filter layer 16 including sub-color filters and a common electrode 13 on the color filter layer 16, and a lower substrate 14 having a thin film transistor (TFT) T and a pixel electrode 20 connected to the TFT T. A liquid crystal layer 18 is interposed between the common electrode 13 and the pixel electrode 20. The lower substrate 14 is referred to as an array substrate because array lines including a gate line 25 and a data line 27 are formed thereon. The gate line 25 and the data line 27 cross each other forming a matrix, and the TFT T is connected to the gate line 25 and the data line 27. The gate line 25 and the data line 27 define a pixel region P by crossing each other, and the TFT T is formed near a crossing portion of the gate line 25 and the data line 27. The pixel electrode 20 is formed of a transparent conductive material such as indium-tin-oxide (ITO) and indium-zinc-oxide (IZO) in the pixel region P. The upper substrate 12 is referred to as a color filter substrate because the color filter layer 16 is formed thereon.

A reflective layer 21 of a reflective material such as aluminum (Al) or Al alloy is formed in the pixel region P. However, when the reflective layer 21 is connected to the pixel electrode 20, the reflective layer 21 can act as an electrode. The reflective layer 21 has a transmittance hole H so that the pixel region P is divided into a reflective portion RP and a transmissive portion TP. The transmissive portion TP corresponds to the transmissive hole H and the reflective portion RP corresponds to the other portions of the reflective layer 21.

However, because the transfective LCD device is manufactured to selectively use a reflective mode or a transmissive mode, utilization efficiency for light is relatively low. Particularly, when the transfective LCD device is used as the reflective mode, it depends on natural light. Therefore, the utilization efficiency is low in comparison with the transmissive mode. As a result, interchanging the reflective mode with the transmissive mode causes a brightness difference.

To solve these problems, an uneven reflective layer is formed on the reflective portion to induce an irregular reflection by minimizing incident light specularly-reflected from outside and to improve the entire brightness of the reflective mode and transmissive mode according to the related art.

Hereinafter, the transfective LCD device having the uneven reflective layer according to the related art will be explained referring to FIG. 2.

FIG. 2 is a schematic plan view showing one pixel region for a transfective LCD device having an uneven reflective layer according to the related art.

In FIG. 2, a gate line 34 is formed on a substrate 30 along a first direction, and a data line 46 crosses the gate line 34 to define a pixel region P.

A thin film transistor T is formed near a crossing of the gate line 34 and the data line 46. A gate electrode 32, a semiconductor layer 41, source and drain electrodes 42 and 44 constitute the thin film transistor T.

A pixel electrode 60 of a transparent conductive material is formed in the pixel region P and is connected to the thin film transistor T. A reflective layer 64 having a plurality of unevennesses 52 is formed in the pixel region P and has a transmissive hole 58 that exposes the central portion of the pixel electrode 60.

The pixel region P includes a transmissive portion TP in the transmissive hole 58 and a reflective portion RP in a portion of the reflective layer 21 except a portion of the transmissive hole 58.

That is to say, the pixel electrode 60 acts as a driving electrode of the liquid crystal layer 18 (of FIG. 1) with the common electrode 13 (of FIG. 1). On the other hand, the reflective layer 64 (or reflective electrode) mainly acts as a reflective means. Therefore, the uneven patterns increase reflectance of a surface of the reflective layer.

Next, it will be explained about the fabricating method for the transfective LCD device having the uneven reflective layer according to the related art.

FIGS. 3A to 3G are schematic cross sectional views taken along lines III-III of FIG. 2, which shows a fabricating process for a transfective LCD device according to the related art.

In FIG. 3A, a switching region S, a transmissive portion TP, and a reflective portion RP in periphery of the transmissive portion TP are defined in a substrate 30. The transmissive and reflective portion TP and RP constitute a pixel region P.

A gate electrode 32 is formed on the substrate 30 in the switching region S. For example, the gate electrode 32 is formed as a single layer or a double layer. When the gate electrode 32 is a single layer, it is selected from one of aluminum (Al), Al alloy, tungsten (W), chromium (Cr) and molybdenum (Mo). Meanwhile, when the gate electrode 32 is a double layer, the gate electrode 32 is selected from one of Al/Cr and Al/Mo.

In FIG. 3B, a gate insulating layer 36 is formed of inorganic insulating materials over an entire surface of the substrate 30 having the gate electrode 32, and an active layer 38 and an ohmic contact layer 40 are sequentially formed on the gate insulating layer 36. The active layer 38 and the ohmic contact layer 40 are made of intrinsic amorphous silicon and the doped amorphous silicon, respectively. The active layer 38 and the ohmic contact layer 40 constitute a semiconductor layer 41.

In FIG. 3C, source and drain electrodes 42 and 44 are formed of a metallic material on the semiconductor layer 41, and a passivation layer 46 is formed of an insulating material on an entire surface of the substrate 30 having the source and drain electrodes 42 and 44. At this time, in order to improve contact between the semiconductor layer 41 and the passivation layer 46, the passivation layer 46 is made of an inorganic insulating material including silicon nitride (SiN_x) and silicon oxide (SiO_x).

In FIG. 3D, a photosensitive layer **50** is formed of a photosensitive material on the passivation layer **46**. The photosensitive material is selected from an organic material such as acrylic resin. This step includes forming an uneven pattern of squares (not shown) in a surface portion of the photosensitive layer **50** and forming the first uneven pattern **51** as a hemispherical shape by melting at a predetermined temperature within about 350 degrees Celsius.

Next, an inorganic insulating layer **54** is formed of a transparent inorganic material on an entire surface of the substrate **30** having the first uneven pattern **51** of the hemispherical shape. At this time, the inorganic insulating layer **54** has a second uneven pattern **52** of a hemispherical shape corresponding to the first uneven pattern **51** of the photosensitive layer **50**. The first and second uneven patterns **51** and **52** are located in the reflective portion RP.

In FIG. 3E, portions of the passivation layer **46**, the photosensitive layer **50** and the inorganic insulating layer **54** that correspond to a portion of the drain electrode **44** and the transmissive portion TP are etched to form a drain contact hole **56** and a transmissive hole **58** that expose the portions of the drain electrode **44** and the transmissive portion TP, respectively. Specifically, a portion of the gate insulating layer **36** in the transmissive hole **58** may be etched due to etching rate differences between a portion of the drain contact hole **56** and a portion of the transmissive hole **58** as shown in FIG. 3E.

In FIG. 3F, a reflective layer **60** is formed of metallic materials having a high reflectance such as aluminum (Al) and silver (Ag) on the substrate **30** having the drain contact hole **56** and the transmissive hole **58**. The reflective layer **60** corresponds to the reflective portion RP except portions of the drain contact hole **56** and the transmissive hole **58**.

In FIG. 3G, an inorganic insulating layer **62** is formed of an inorganic insulating material on the substrate **30** having the reflective layer **60**. At this time, through this step, the inorganic insulating layer **62** has holes corresponding to the drain contact hole **56** and the transmissive hole **58** that can expose the portion of the drain electrode **42** and the transmissive portion TP.

Next, a pixel electrode **64** is formed of transparent conductive materials such as indium tin oxide (ITO) on the inorganic insulating layer **62** and is connected to the drain electrode **44** via the drain contact hole **56**.

As explained above, the transfective LCD device according to the related art is manufactured.

However, this method of fabricating for the transfective LCD device according to the related art uses a large number of processes and thus the overall process becomes complicated. Therefore, production yield of the transfective LCD device is reduced.

SUMMARY

By way of introduction only, in one aspect, a transfective liquid crystal display device includes: a first substrate; a second substrate facing the first substrate; a liquid crystal layer interposed between the first and second substrates; a first polarizer on an outer side of the first substrate; a second polarizer on an outer side of the second substrate; an uneven transfective film on the first polarizer; and a backlight unit outside of the uneven transfective film.

In another aspect, an uneven transfective film includes: a base film including a plurality of convex patterns and a plurality of concave portions between the plurality of convex patterns; and a reflective layer in the plurality of concave portions. The reflective layer is formed on the concave patterns but not on the convex patterns. Each convex portion is

defined from an apex of the curves in the base film (where the slope is zero) to a predetermined distance from the apex (where the slope is a set value). Each concave portion is defined from the predetermined distance from the apex to the point where the curve meets the adjacent curve or the curve otherwise terminates. The area of the convex portion bounded by the predetermined distance defines the open area in which light is transmitted through the film.

In another aspect, a method of fabricating an uneven transfective film includes: forming a plurality of convex patterns on a base film; forming a reflective material layer on an entire surface of the convex patterns; and etching the reflective material layer corresponding to the convex patterns to form a reflective layer between the convex patterns.

It is to be understood that both the foregoing general description and the following detailed description of the present invention are exemplary and explanatory and are intended to provide further explanation of the invention as claimed.

BRIEF DESCRIPTION OF THE DRAWINGS

The accompanying drawings, which are included to provide a further understanding of the invention and are incorporated in and constitute a part of this application, illustrate embodiments of the invention and together with the description serve to explain the principles of the invention.

In the drawings:

FIG. 1 is an exploded perspective view of an LCD device according to the related art.

FIG. 2 is a schematic plan view showing one pixel region for a transfective LCD device having an uneven reflective layer according to the related art.

FIGS. 3A to 3G are schematic cross sectional views taken along lines III-III of FIG. 2, which shows a fabricating process for a transfective LCD device according to the related art.

FIG. 4 is a schematic plan view showing one pixel region for a transfective LCD device having the uneven reflective layer according to the present invention.

FIG. 5 is a schematic plan view of an uneven transfective film according to the present invention.

FIGS. 6A to 6E are schematic cross sectional views of a fabricating process for the uneven transfective film according to the present invention.

FIG. 7 is a schematic plan view of a reflective layer of an uneven transfective film according to the present invention.

DETAILED DESCRIPTION OF THE EMBODIMENTS

Reference will now be made in detail to the illustrated embodiments of the present invention, examples of which are illustrated in the accompanying drawings.

FIG. 4 is a schematic plan view showing a transfective LCD device having an uneven transfective film according to one embodiment of the present invention.

In FIG. 4, an LCD device **100** includes a first substrate **200**, a second substrate **300** facing the first substrate **200**, a liquid crystal layer **400** interposed between the first and second substrates **200** and **300**, a first polarizer PL1 on an outer side of the first substrate **200**, a second polarizer PL2 on an outer side of the second substrate **300**.

At this time, a pixel region P is defined in each of the first and second substrates **200** and **300**. A gate electrode **202** is formed on the first substrate **200**, a semiconductor layer **206** over the gate electrode **202**, and source and drain electrodes

208 and 210 on the semiconductor layer 206. The gate electrode 202, the semiconductor layer 206, and the source and drain electrodes 208 and 210 constitute a thin film transistor T. A pixel electrode 214 is formed in the pixel region P of the first substrate 200 and is connected to the thin film transistor T.

A black matrix 302 is formed on the second substrate 300, a color filter layer 304 on the black matrix 302. The color filter layer 304 includes a red sub-color filter 304a, a green sub-color filter 304b and a blue sub-color filter (not shown). Each of the red sub-color filter 304a, the green sub-color filter 304b and the blue sub-color filter (not shown) is located in the pixel region P. A common electrode 306 is formed on an entire surface of the color filter layer 304. In addition, a liquid crystal layer 400 is interposed between the pixel electrode 214 and the common electrode 306.

Although not shown, the black matrix 302 corresponds to a portion of the thin film transistor T and a portion that a gate line and a data line.

In addition, an uneven transfective film 500 is disposed on the first polarizer PL1, and a backlight unit BL is disposed outside of the uneven transfective film 500. At this time, the uneven transfective film 500 includes a plurality of convex patterns 502 having hemispherical shapes that face toward an inner side of the liquid crystal device 100 and a reflective layer 504 between the convex patterns 502.

Although not shown, a portion of the reflective layer 504 corresponds to a reflection region where a first incident light L1 from natural ambient light is reflected, and a portion of the convex patterns 502 corresponds to a transmission region where a second incident light L2 from the backlight unit BL is transmitted.

Therefore, the LCD device can be both driven a reflective mode and a transmissive mode by the uneven transfective film without a reflective pattern such as the reflective layer 60 (of FIG. 3F) inner side of the LCD device. Specifically, because of the hemispherical shape of the convex pattern 502, the transfective LCD device according to one embodiment of the present invention can obtain high reflection efficiency and a wide-angle property. Although not shown, the uneven transfective film 500 and the first polarizer PL1 may be unified as a single body.

Hereinafter, a specific structure of the uneven transfective film 500 will be explained as referring to FIG. 5.

FIG. 5 is a schematic plan view of an uneven transfective film according to one embodiment of the present invention.

In FIG. 5, an uneven transfective film 600 includes a base film 602 including a plurality of convex patterns 604 and a plurality of concave portions CP between the plurality of convex patterns 604, and a reflective layer 606 in the plurality of concave portions CP. In addition, a passivation layer 608 on the convex patterns 604 and the reflective layer 606.

The base film 602 and the passivation layer 608 are selected from transparent materials. Specifically, the base film 602 is selected from a polymer based material such as polyester. The reflective layer 606 is selected from a metallic material having a high reflectance such as aluminum (Al) and silver (Ag).

Specifically, the convex pattern 604 has a hemispherical shape to improve reflection efficiency. Although not shown, the reflective layer 606 may be formed as a single layer having open portions OP that correspond to the convex patterns 604. In other words, a portion of the convex pattern 604 is exposed through the open portion OP of the reflective layer 606. Therefore, a portion of the reflective layer 606 between the convex patterns 604 is defined by a reflection region RR where incident light from in the top portion is reflected, a portion of the convex pattern 604 corresponding to the open

portion OP is defined by a transmission region TR where incident light from outside in a back side of the convex pattern 604 is transmitted.

Accordingly, the reflection efficiency increases, interference is prevented, and the viewing angle is improved by using the uneven transfective film 600 having the convex patterns 604 and the reflective layer 606.

Hereinafter, a method of fabricating the uneven transfective film according to the present invention will be explained referring to FIGS. 6A to 6E.

In FIG. 6A, a base film 602 that is selected from a polymer based material such as polyester is prepared.

Next, in FIG. 6B, a plurality of convex patterns 604 are formed by stamping the top surface of the base film 602. Each convex pattern 604 has a hemispherical shape.

That is to say, the transfective LCD device having the uneven transfective film 600 is manufactured simpler process than the transfective LCD device of the related art by omitting photolithography and melting of the reflective layer 64 (of FIG. 2) having the uneven patterns 52 (of FIG. 2).

In FIG. 6C, a reflective material layer 605 is formed on an entire surface of the convex patterns 604. The reflective material layer 605 is selected from a metallic material having a high reflectance such as aluminum (Al) and silver (Ag).

In FIG. 6D, the reflective material layer 605 (of FIG. 6C) corresponding to the convex patterns 604 is removed by etching to form a reflective layer 606 between the convex patterns 604. For example, etching of the reflective material layer 605 (of FIG. 6C) is performed using photolithography.

In FIG. 6E, a passivation layer 608 is formed on an entire surface of the convex patterns 604 and the reflective layer 606.

The base film 602 having the convex patterns 604, the reflective layer 606, and the passivation layer 608 constitute an uneven transfective film 600.

Hereinafter, a plan structure of the reflective layer of the uneven transfective film 600 according to the present invention will be explained as referring to FIG. 7.

As shown in FIG. 7, the reflective layer 606 is formed as a single body and has open portions OP corresponding to the convex patterns 604. For example, the open portions OP have hexagonal shapes. However, the open portions OP can have other shapes in combination with or instead of the hexagonal shapes.

As explained above, this uneven transfective film 600 can be easily applied to the LCD device and can effectively improve reflection efficiency.

Consequently, a transfective LCD device according to embodiments of the present invention has following advantages. First, the transfective LCD device can be both utilized in transmissive and reflective modes by including an uneven transfective film. Therefore, the transfective LCD device can be manufactured through a simpler process than that of the related art. Moreover, defect probability in the process, process time, and process cost can be reduced, thereby improving process yield and market competitiveness of production. Second, reflection and transmission efficiency can be increased. Third, because of the hemispherical shape of the uneven transfective film, the brightness of the display can be viewed in a wider angular range.

It will be apparent to those skilled in the art that various modifications and variations can be made in a transfective LCD device and a fabricating method thereof of the present invention without departing from the spirit or scope of the invention. Thus, it is intended that the present invention cover

7

the modifications and variations of this invention provided they come within the scope of the appended claims and their equivalents.

What is claimed is:

1. A method of fabricating an uneven transfective film, the method comprising:
 stamping a surface of a base film to form a plurality of convex patterns and a plurality of concave patterns, the plurality of convex patterns having a hemispherical shape on a base film;
 forming a reflective material layer on an entire surface of the convex patterns and the plurality of concave patterns; and
 etching the reflective material layer corresponding to the convex patterns to form a reflective layer on an entire top surface of the base film excluding the plurality of convex patterns,
 wherein at least one of the plurality of convex patterns is disposed in a center of a pixel region, and
 wherein each concave pattern has a V shape, and a thickness of the reflective layer corresponding to a center of

8

the each concave pattern is greater than a thickness of the reflective layer corresponding to edges of the each concave pattern.

2. The method according to claim 1, wherein etching the reflective material layer utilizes photolithography.

3. The method according to claim 1, wherein each of the convex patterns has a hemispherical shape.

4. The method according to claim 1, wherein the reflective layer is a single layer.

5. The method according to claim 1, wherein the reflective material layer is etched such that no reflective layer remains on the convex patterns that are corresponding to open portions of the uneven transfective film that are not covered by a reflective material.

6. The method according to claim 5, wherein the reflective material layer is etched such that the reflective layer only remains between the convex patterns that are corresponding to the open portions of the uneven transfective film that are not covered by the reflective material.

* * * * *

专利名称(译)	透反液晶显示装置及其制造方法		
公开(公告)号	US7545465	公开(公告)日	2009-06-09
申请号	US11/025219	申请日	2004-12-28
[标]申请(专利权)人(译)	乐金显示有限公司		
申请(专利权)人(译)	LG 飞利浦LCD CO. , LTD.		
当前申请(专利权)人(译)	LG DISPLAY CO. LTD.		
[标]发明人	NAM CHUL		
发明人	NAM, CHUL		
IPC分类号	G02F1/1335 G02B1/10 G02F1/133 G02F1/136		
CPC分类号	G02F1/13355		
代理机构(译)	BRINKS霍费尔GILSON & LIONE		
审查员(译)	内尔姆斯, DAVID		
优先权	1020030099358 2003-12-29 KR		
其他公开文献	US20050140879A1		
外部链接	Espacenet USPTO		

摘要(译)

透反液晶显示装置包括相对的基板，该基板具有插入在基板之间的液晶层。偏振器设置在基板的外侧。不均匀的透射反射膜设置在一个偏振器上。背光单元设置在不均匀的半透半反膜的外部。不均匀的透射反射膜包括基膜，基膜上的凸起图案和凸起图案之间的凹入部分中的反射层。钝化层设置在凸起图案和反射层上。来自背光单元的光透过凸起图案，并且环境光被凹入部分中的反射层反射。

